## 501762485 12/20/2011

## PATENT ASSIGNMENT

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| NATURE OF CONVEYANCE: | ASSIGNMENT     |

## CONVEYING PARTY DATA

| Name           | Execution Date |
|----------------|----------------|
| Huilong Zhu    | 11/11/2011     |
| Miao Xu        | 11/11/2011     |
| Qingqing Liang | 11/11/2011     |

#### RECEIVING PARTY DATA

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| State/Country:    | CHINA  |
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### PROPERTY NUMBERS Total: 1

| Property Type       | Number   |
|---------------------|----------|
| Application Number: | 13379433 |

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Total Attachments: 2

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PATENT REEL: 027418 FRAME: 0522 OP \$40.00 13379433

## ASSIGNMENT

WHEREAS, We , Huilong ZHU of 93 Autumn Dr. Poughkeepsie, New York 12603, United States of America; Miao XU of No.3 Beitucheng West Road, Chaoyang District, Beijing 100029, China; Qingqing LIANG of 28 Reggies Way, Lagrangeville, New York 12540, United States of America, (hereinafter referred to as ASSIGNORS), are the inventors of an invention described in an application for Letters Fatent of the United States entitled MOSFET AND METHOD FOR MANUFACTURING THE SAME, the application having been associated on even dare herewith, and/or being localization in the United States ratent and Trademark Office by Application No.

WHEREAS, INSTITUTE OF MICROELECTRONICS, CHINESE ACADEMY OF SCIENCES, a corporation organized and existing under the laws of the Country of F.R. CHINA, and having offices at Mo.3 Beltucheng West Road, Chaoyang District, Beijing 100029, China, ("Assignes") is desirous of acquiring the entire right, title and interest in and to the invention, the application, and any and all Letters Patent or similar legal protection, foreign or domestic, to be obtained therefor;

NOW, THEREFORE, for good and valuable consideration, the receipt and adequacy of which is hereby acknowledged, I transfer to Assignee, its successors and assigns, my entire right, title and interest in and to the invention, the above-identified application, all Letters Patent or similar legal protection issuing thereon in the United States, and I authorize the Director of the United States Fatent and Trademark Office to issue the Letters Patent or similar legal protection to the Assignee.

I authorize the Assignee, its auccessors and assigne, to insert in this instrument the filing date and serial number of the application when ascertained.

I authorize the Assignee, its successors and assigns, or anyone it may properly designate, to apply for Letters Patent or similar legal protection, in its own name if desired, in any and all foreign countries.

We represent to the Assignee, its successors and assigns, that we have not and shall not execute any writing or do any act whatsoever conflicting with this Assignment. We, our executors or administrators, will at any time upon request, without additional consideration, but at the expense of the Assignee, its successors and assigns, execute such additional writings and do such additional acts as the Assignee, its successors and assigns, may deem desirable to perfect its enjoyment of this grant, and render all assistance in making application for and obtaining, maintaining, and enforcing the Letters Patent or similar legal protection on the invention in the United States.

Huilong ZMU Anventor

(Witness Printed Name)

Fan Yang (Witness Signature)

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| Qingging Liams (Inventor)               | Date:           | 11 4/204               |         |
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